

DO NOT ENTER



Attorney Docket No. 0756-7275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hidekazu MIYAIRI et al.

Serial No. 10/808,499

Filed: March 25, 2004

For: METHOD FOR TESTING

SEMICONDUCTOR FILM,

SEMICONDUCTOR DEVICE AND

MANUFACTURING METHOD

THEREOF

) Group Art Unit: 2857

) Examiner: J. West

) CERTIFICATE OF MAILING

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2009.

Adrian M. Stanger

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 19, 2008, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.